

- L22: (1185235) pad bump ball
 -L24: (32) 12 and 22
 -L23: (16) 21 and 22
 -L25: (45) 8 21
 -L26: (19) 25 and 22
 -L27: (0) Forward citation search 1
 -L28: (34) Backward citation search 1
 -L29: (8) 28 and 4
 -L30: (0) Forward citation search 2
 -L31: (15) Backward citation search 2
 -L32: (0) 31 and 4
 -L33: (8) Forward citation search 3
 -L34: (20) Backward citation search 3
 -L35: (11) 34 and 4
 -L38: (538762) (polysilicon silicon)
 -L37: (9553) 22 near4 36
 -L39: (69) 38 and 5
 -L38: (117) 37 and 4
 -L40: (44370) (repair\$4 edit\$4 5) near6 9
 -L41: (7007) 40.ab.
 -L42: (1) 38 and 41
 -L43: (77) 38 and 40
 Failed
 - ((multilevel\$4 multilayer\$4 (multi\$4 plural\$4) adj (layer\$4 level\$4)) ad

[illegible]

821

Feb, 2005

	U	Inventor	Document/Issue P	Title	Current	Current X	Retrieval	S	C	P	Y	Image Doc P
1	<input type="checkbox"/>	Kolachina	US 200500	2005 : 1 Focused ion beam endpoint detection	324/75			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20050
2	<input type="checkbox"/>	Kane; Tere	US 667071	:2003 : 1 Structure and method for charge sensi	257/777	257/48;		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 66707
3	<input type="checkbox"/>	Hartswick	US 662792	:2003 : 1 Method of designing and structure for	257/21	257/48;		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 66279
4	<input type="checkbox"/>	Chandler	US 621152	:2001 : 1 Method for device editing	250/49	257/E21.2		<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 62115
5	<input type="checkbox"/>	Hamann, H	US 200500	:2005 : 2 SYSTEM AND METHODS OF ALTER	216/82			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20050
6	<input checked="" type="checkbox"/>	Hamann, H	US 200500	:2005 : 9 SYSTEM AND METHOD OF ALTERIN	216/57			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20050
7	<input checked="" type="checkbox"/>	Suthar, Sail	US 200402	:2004 : 9 Interconnect routing over semiconduct	257/48			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20040
8	<input checked="" type="checkbox"/>	Huynh, Ch	US 200402	:2004 : 1 Dummy copper deprocessing	438/72			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20040
9	<input checked="" type="checkbox"/>	Herschbein	US 200401	:2004 : 1 DRY ETCH PROCESS TO EDIT COPP	216/39			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20040
10	<input checked="" type="checkbox"/>	Marchman	US 200401	:2004 : 2 APPARATUS AND TECHNIQUES FOR	250/49			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	US 20040